



**ELECTRONIC COPY**

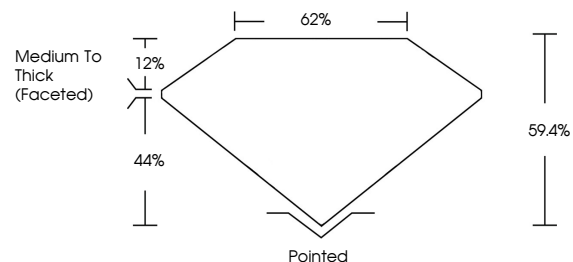
LG768628487  
Report verification at igi.org



February 23, 2026  
IGI Report Number **LG768628487**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **16.90 X 11.29 X 6.71 MM**  
**GRADING RESULTS**  
Carat Weight **8.01 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

February 23, 2026  
IGI Report Number **LG768628487**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **16.90 X 11.29 X 6.71 MM**

**PROPORTIONS**

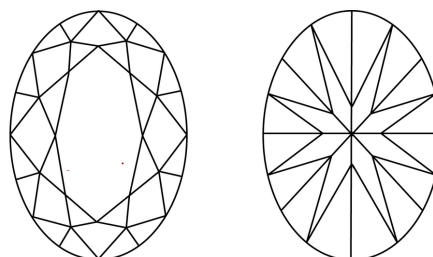


Sample Image Used

**GRADING RESULTS**

Carat Weight **8.01 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768628487**

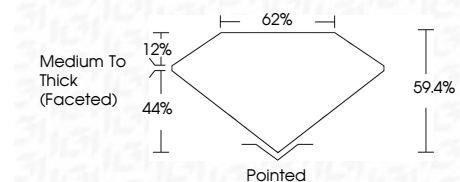
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768628487**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



February 23, 2026  
IGI Report No **LG768628487**  
**OVAL BRILLIANT**  
16.90 X 11.29 X 6.71 MM  
8.01 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **59.4%**  
Table **62%**  
Girdle **Medium To Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768628487**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa